## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Applicant

Vladimir M. Segal et al.

Application No.:

to be assigned

Filed

Herewith

Title

HIGH-STRENGTH SPUTTERING TARGETS AND

METHOD OF MAKING SAMEn

Grp./Div.

to be assigned

Examiner

to be assigned

Docket No.

33507/VGG/J104

## INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents Washington, D.C. 20231

Post Office Box 7068 Pasadena, CA 91109-7068 December 16, 1999

## Commissioner:

In compliance with the duty of disclosure under 37 CFR §§ 1.56, 1.97 and 1.98, and in accordance with the provisions in the Manual of Patent Examining Procedure §§ 609 and 707.05(b), enclosed is FORM PTO-1449 listing the references that are known to applicant. Copies of each of the listed references are enclosed.

It is respectfully requested that the listed references be considered in the examination of this application and identified on the list of references cited on the patent issuing for this application. Applicant also requests that an initialed copy of FORM PTO-1449 be entered in the application file and returned to applicant with the next communication from the Office in accordance with MPEP § 609.

Respectfully submitted,

CHRISTIE, PARKER & HALE, LLP

Vincent G. Gioia

Reg. No. 19,959 626/795-9900

VGG/bie

Enclosures: PTO-1449, w/references

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